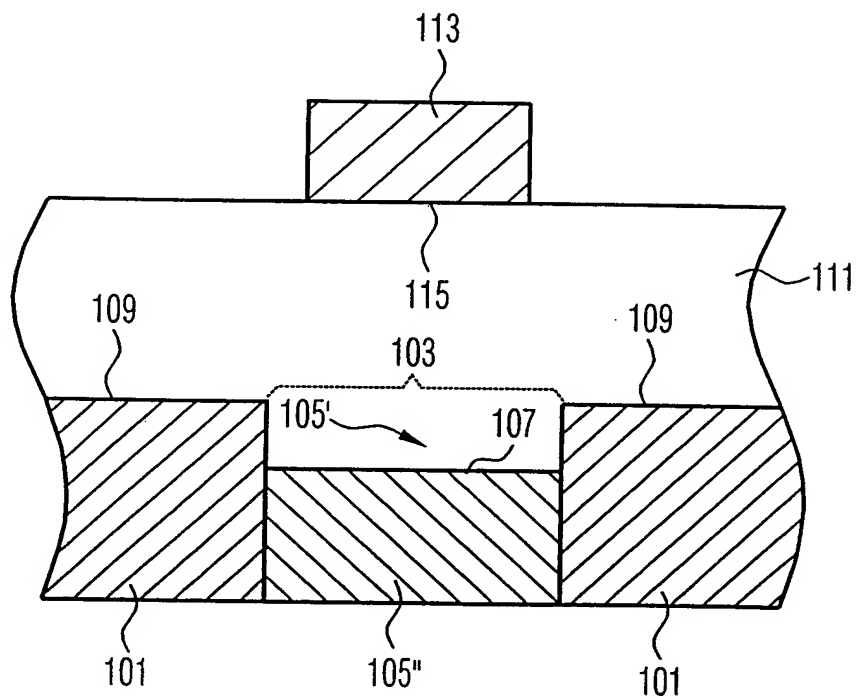


## REPLACEMENT SHEET

Title: Semiconductor Structure with Increased  
Breakdown Voltage and Method for Producing the  
Semiconductor Structure  
Inventor: Tilke et al.  
Serial No.: 10/780,276  
MMB Docket No.: 1890-0061



FIG 1



**FIG 2**

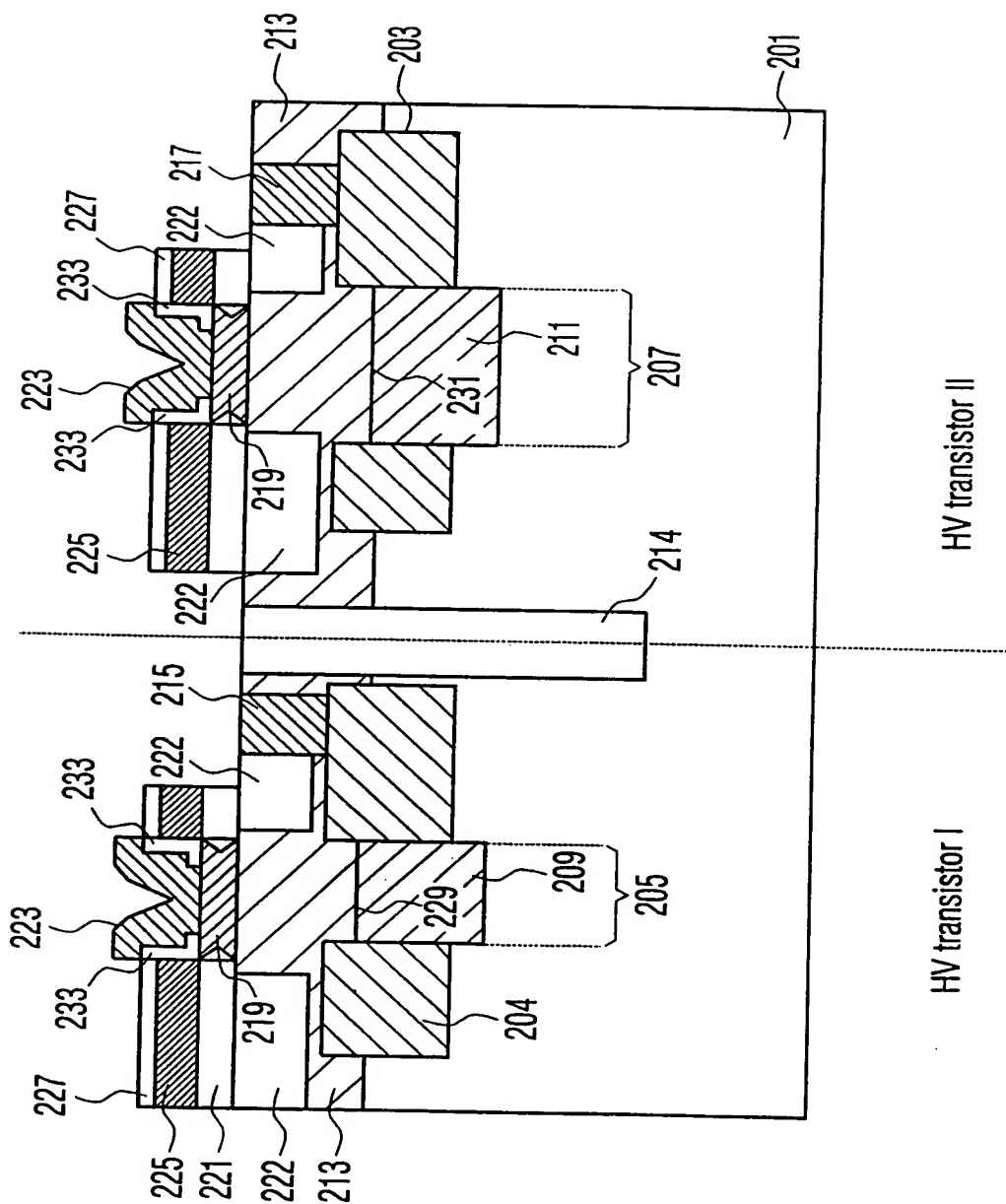
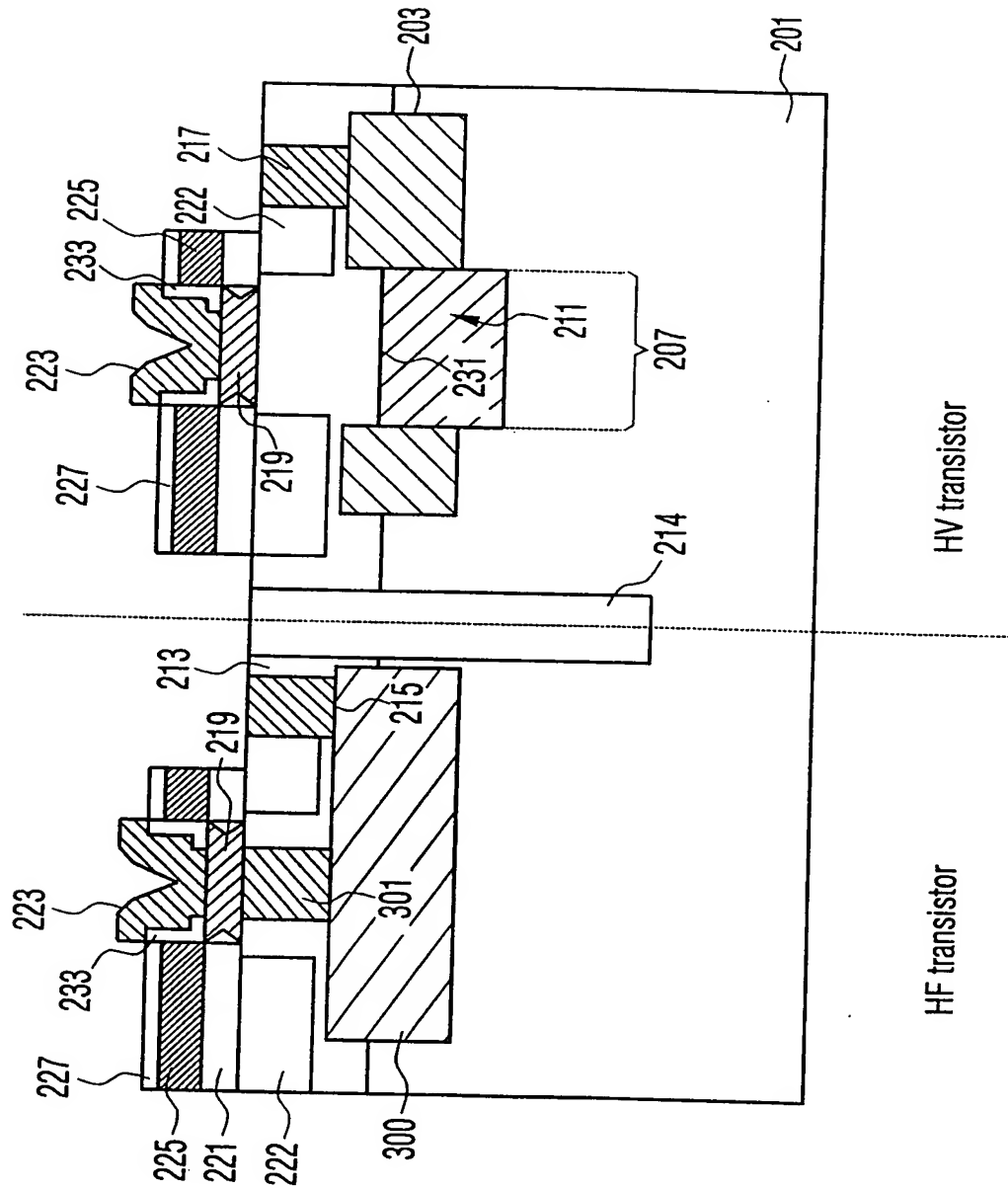


FIG 3



**FIG 4**

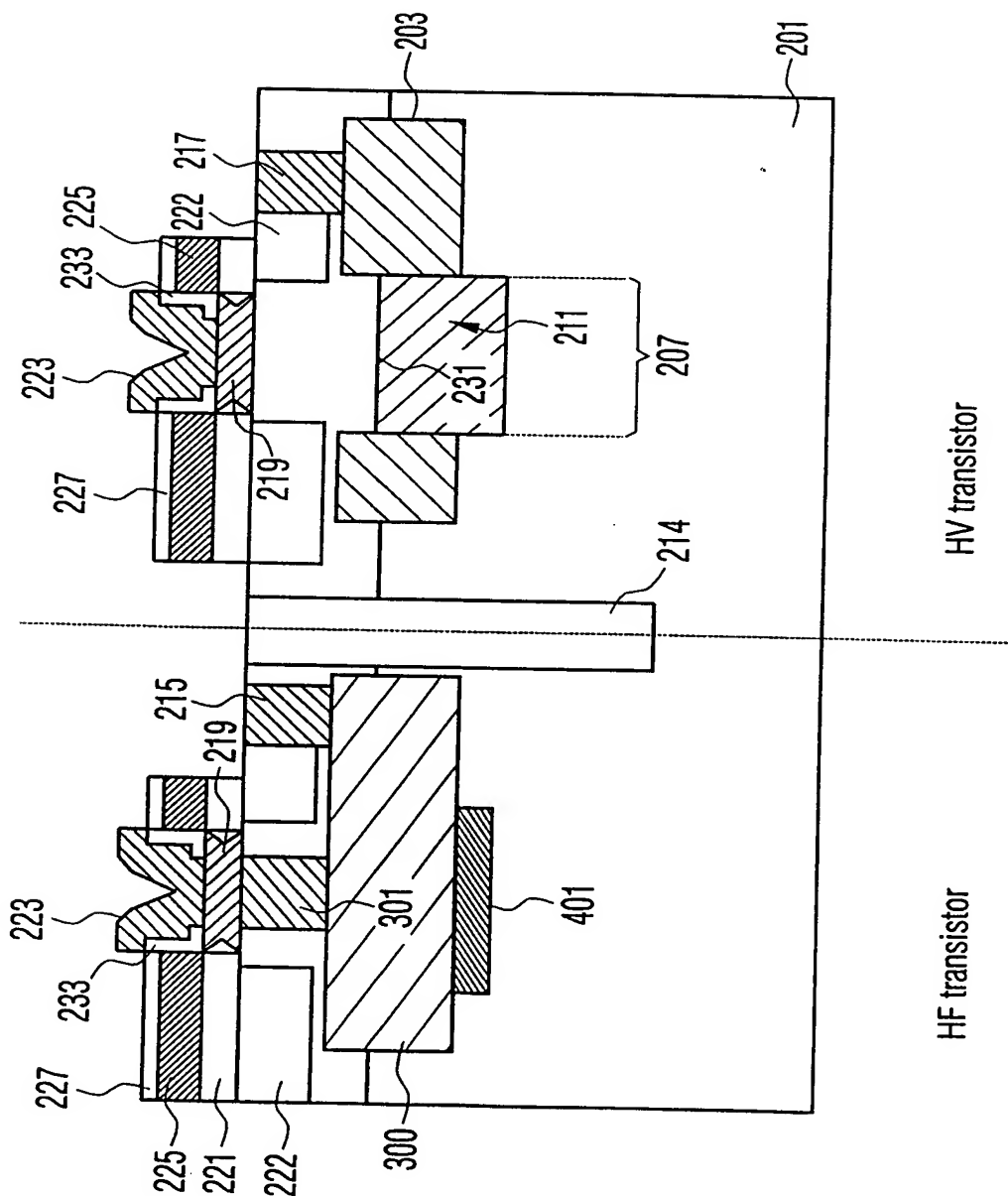
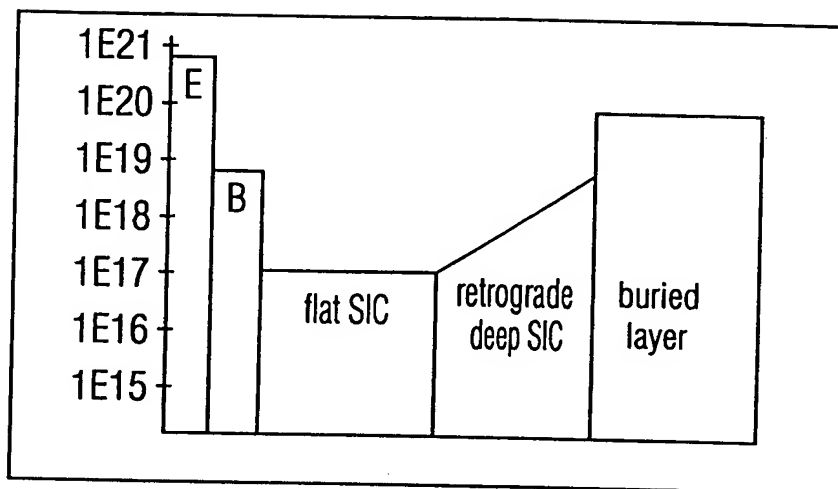


FIG 5

A)



B)

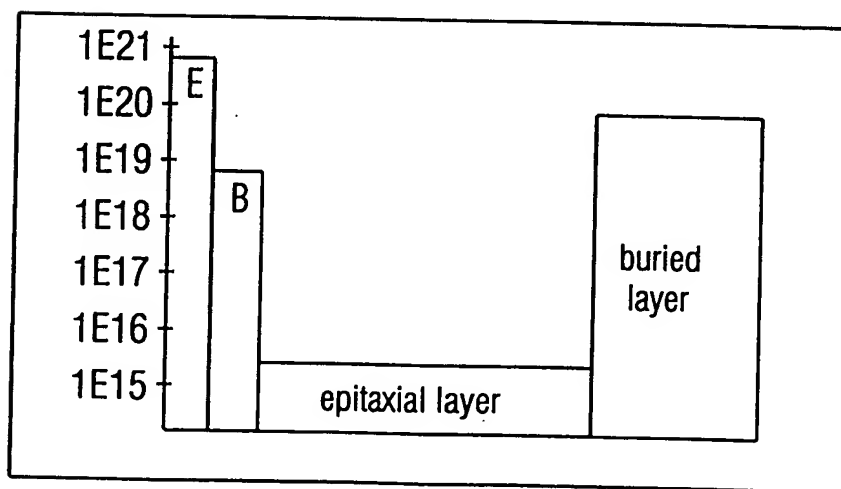
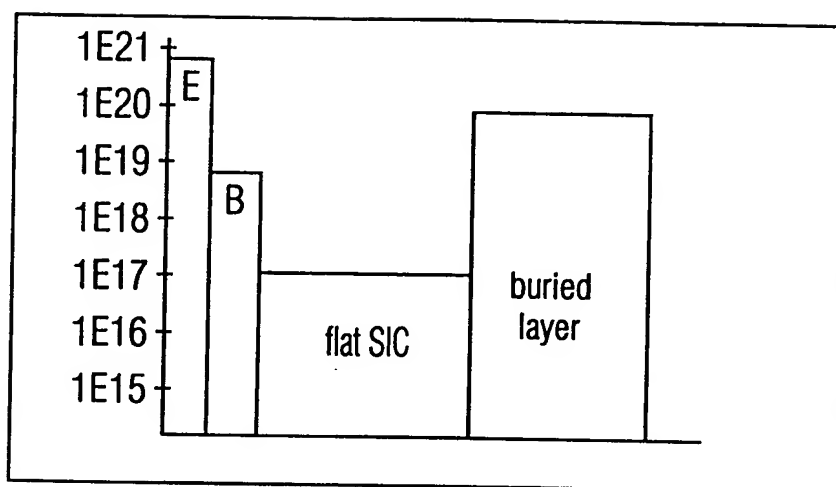


FIG 6

A)



B)

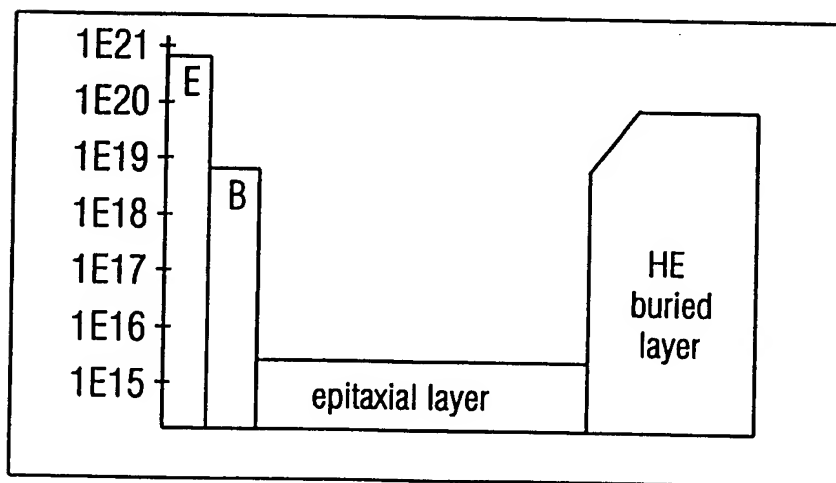


FIG 7

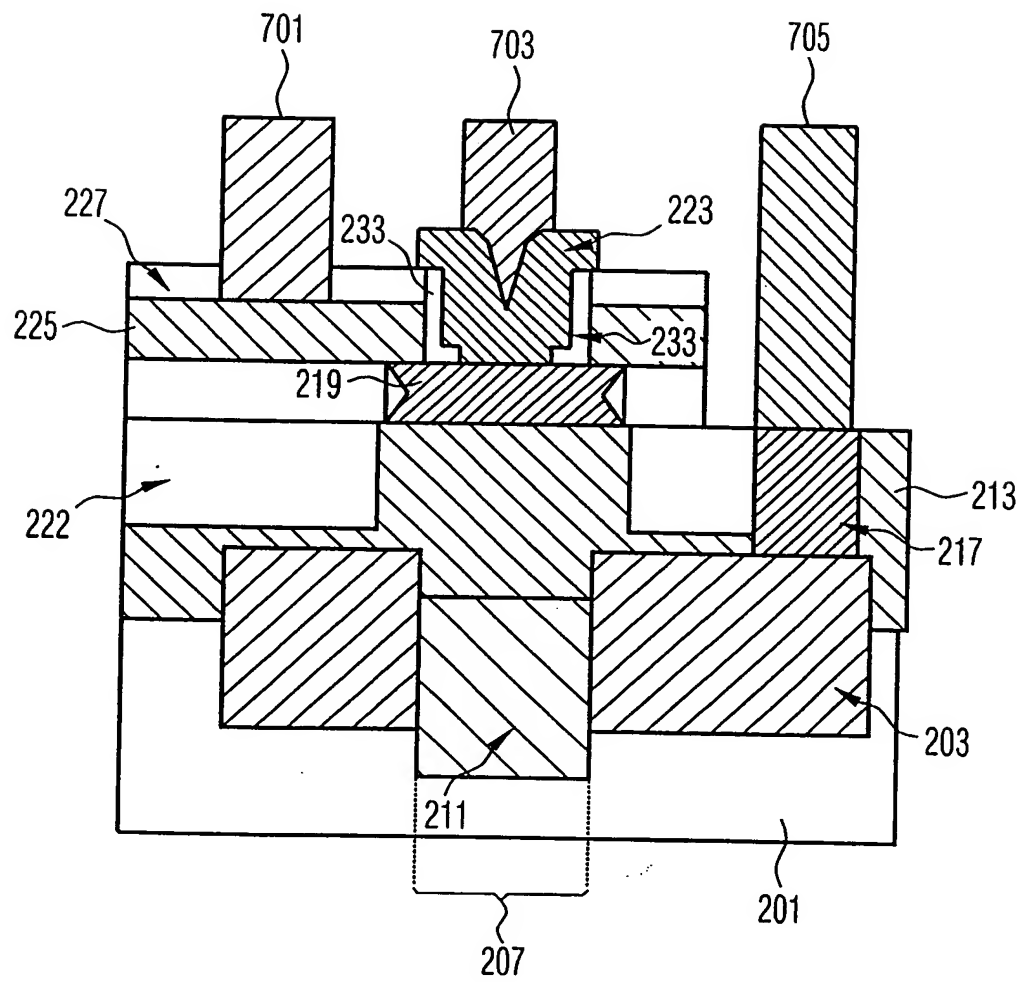


FIG 8

